

**Tentative Program**  
**Autumn School on Advanced 2D and Thin-Film Materials: Processing, Device  
 Fabrication and Characterization**  
**Electroceramics XX - 2026**

<b>9th October</b>	<b>Afternoon - Social event (Optional)</b>
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<b>10th October</b>	<b>8:00 – 8:30</b>	<i>Registration</i>
	<b>8:30 – 9:00</b>	<b>Welcome presentation (BioSense and Introduction to School topic)</b>
	<b>9:00 – 10:30</b>	<b>Lecture 1</b>
	<b>10:30 – 10:45</b>	<i>Coffee Break</i>
	<b>10:45 – 12:15</b>	<b>Lecture 2</b>
	<b>12:15 – 13:00</b>	<i>Lunch Break</i>
	<b>13:00 – 14:30</b>	<b>Lecture 3</b>
	<b>14:30 – 14:45</b>	<i>Coffee Break</i>
	<b>14:45 – 15:30</b>	<b>Lab Session 1 : Clean room (PVD, FIB)</b>
	<b>15:30 – 16:15</b>	<b>Lab Session 2 : Chemical Lab (2D materials synthesis)</b>
	<b>School Dinner</b>	

<b>11th October</b>	<b>8:45 – 10:15</b>	<b>Lecture 4</b>
	<b>10:15 – 10:30</b>	<i>Coffee Break</i>
	<b>10:30 – 12:00</b>	<b>Lecture 5</b>
	<b>12:00 – 13:00</b>	<i>Lunch Break</i>
	<b>13:00 – 14:30</b>	<b>Lecture 6</b>
	<b>14:30 – 14:45</b>	<i>Coffee Break</i>
	<b>14:45 – 15:30</b>	<b>Lab Session 3 : Electrolab (FET – basics, integration of materials into devices and evaluation of their impact)</b>
	<b>15:30 – 16:45</b>	<b>Lab Session 4 : Characterization (XRD – thin films, SEM, AFM, Device functional measurements)</b>



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**NOVI SAD**  
**12-15 OCTOBER 2026**  
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